Attorney Docket No. 0756-7244

MAY 1 6 2007 ON THE UNITE

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

in the atent Application of:)	Group Art Unit: 2822
Koichiro TANAKA et al.)	Examiner: Mary A. Wilczewski
Serial No. 10/749,505)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 14, 2007.
Filed: January 2, 2004)	
For: LASER/IRRADIATION METHOD,) .	
METHOD FOR MANUFACTURING)	
SEMICONDUCTOR DEVICE, AND)	adele M Stamper
LASER IRRADIATION SYSTEM)	/

<u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated February 12, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 15 of this paper.